Application/Control No.	Applicant(s)/Patent under Reexamination
10/709,984	LEE, WEN-CHIN
Examiner	Art Unit
Michael P. Choi	2621

	SEARCHED				
Class	Subclass	Date	Examiner		
386	1,46,52,55	9/25/2007	мс		
386	69,95	9/25/2007	мс		
386	111-112	9/25/2007	мс		
386	125-126	9/25/2007	МС		
348	461,469	9/25/2007	МС		
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INTERFERENCE SEARCHED				
Subclass	Date	Examiner		
1				
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SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
Inventor Search in eDan	9/20/2007	MC		
EAST Search History	9/25/2007	МС		